



**\*EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>				Docket Number, (Optional) <b>FUJI:266</b>	Application Number <b>NEW APPLICATION</b>		
				Applicant(s) <b>Makoto UTUMI et al.</b>			
				Filing Date <b>July 22, 2003</b>	Group Art Unit <b>1774</b>		
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<b>FOREIGN PATENT DOCUMENTS</b>							
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES      NO
<i>DY</i>	JP	2000-214318	8/00	JAPAN (Eng. Abst.)	—	—	<input checked="" type="checkbox"/> X      —
<b>OTHER DOCUMENTS</b> <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
EXAMINER	<i>Dawn L Garrett</i>	DATE CONSIDERED <i>2/10/2005</i>					
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